



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **WATANABE, et al.**

Serial No.: **09/320,271**

Group Art Unit: **2825**

Filed: **May 27, 1999**

Examiner: **Calvin Lee**

P.T.O. Confirmation No.: **4409**

For: **SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*35H/Amend F*  
*10/2/13*

September 22, 2003

Sir:

*al/Bm*

In response to the Office Action dated **May 23, 2003**, extended to **September 23, 2003** by  
a **1 month** Petition for Extension of Time, please amend the above-identified application as follows:

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